



2811

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
CHANGE OF ADDRESS OF APPLICANTS' REPRESENTATIVES

#9
1-12-01
L Hallman

APPLICANT: Gerald Deboy, et al

Case No.: P00,0578

SERIAL NO.: 09/ 530,553

GROUP ART UNIT: 2811

DATE FILED: July 21, 2000

EXAMINER:

INVENTION: HIGH VOLTAGE RESISTANT EDGE STRUCTURE FOR SEMICONDUCTOR COMPONENTS

Assistant Commissioner of Patents and Trademarks
Washington DC 20231

S I R:

Members of the Firm of Hill & Simpson designated on the original Power of Attorney have merged into the firm of Schiff Hardin & Waite. All future correspondence for the above-referenced application therefore should be sent to the following address:

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Respectfully submitted,


(Reg. No. 24,149)

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